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12/19/01

U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

APPLICATION		FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU		
10025085	12/19/2001	438	636	2913 2012		T. Pham
<p>**APPLICANTS: Ian Cher; Mukherjee-Roy Moitreyee; Foo Pang;</p>						
<p>**CONTINUING DATA VERIFIED:</p>						
<p>** FOREIGN APPLICATIONS VERIFIED: SINGAPORE 200105179-6 08/24/2001</p>						
PG-PUB		DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>		
Foreign priority claimed		<input type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO		
35 USC 119 conditions met		<input type="checkbox"/> yes <input type="checkbox"/> no		2085-00600 (IME-P002US)		
Verified and Acknowledged Examiners's initials						
<p>TITLE : Method for preventing photoresist poisoning in semiconductor fabrication</p>						

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NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drwg.	Figs.Drwg. Print Fig.
<input type="checkbox"/> TERMINAL DISCLAIMER		Primary Examiner Application Examiner	
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